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R石林

Electronic Information Disclosure Statement




NITRIDE ETCHSTOP FILM TO PROTECT METAL-INSULATOR-METAL CAPACITOR DIELECTRIC FROM DEGRADATION AND METHOD FOR MAKING SAME



jc474 U.S. PTO
10/065843
11/25/02

Application:
Confirmation:
Applicant(s): John Malinowski
Docket Number: BUR920010074
Group Art Unit:
Examiner: unknown
search string: (6222222 or 6107136 or 61366659 or 6165891 or 6168992).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	6222222	2001-04-24		DeBoer et al.		
	P02	6107136	2000-08-22		Melnick et al.		
	P03	61366659	2000-10-24		Schindler et al.		

	P04	6165891	2000-12-26		Chooi et al.
	P05	6168992	2001-01-02		Lee

Signature

Examiner Name	Date